



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Sergiy Yakovlevich NAVALA, et al.

Art Unit: 2828

Serial No. 10/755,452

Examiner: H. Philogene

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Confirmation No. 1075

For: MAGNETRON CATHODE AND
MAGNETRON SPUTTERING
APPARATUS COMPRISING THE SAME

Attorney Docket No. 249/439

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office action dated August 10, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in a listing of claims, which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.

An **Appendix** including amended drawing figures is attached following page 21 of this paper.